

## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasufumi NISHII et al. Group Art Unit: 2851

Application No.: 10/582,268 Examiner: M. LIU

Filed: June 9, 2006 Docket No.: 128375

For: STAGE APPARATUS, EXPOSURE APPARATUS, AND EXPOSURE METHOD

WITH RECOVERY DEVICE HAVING LYOPHILIC PORTION

## **AMENDMENT FILED WITH RCE**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the September 1, 2009 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, and after entry of the Request for Continued Examination (RCE) filed herewith, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and Remarks.